Electronic Acknowledgement Receipt

EFS ID:	1432269
Application Number:	10685251
International Application Number:	
Confirmation Number:	3992
Title of Invention:	Process for producing low defect density silicon
First Named Inventor/Applicant Name:	Robert J. Falster
Customer Number:	321
Filer:	Richard A. Schuth/Sally Taylor
Filer Authorized By:	Richard A. Schuth
Attorney Docket Number:	MEMC 96-0056 (2101.3)
Receipt Date:	11-JAN-2007
Filing Date:	14-OCT-2003
Time Stamp:	14:21:57
Application Type:	Utility

Payment information:

Submitted with Payment	yes
Payment was successfully received in RAM	$200
RAM confirmation Number	1562
Deposit Account	191345

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)

1	Petition for review by the Technology Center SPRE.	00326558.PDF	19406	no	2
Warnings:					
Information:					
2	Fee Worksheet (PTO-06)	fee-info.pdf	8170	no	2
Warnings:					
Information:					
			Total Files Size (in bytes):	27576	

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New Applications Under 35 U.S.C. 111
If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371
If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.